

<b>Notice of References Cited</b>	Application/Control No. 10/783,520	Applicant(s)/Patent Under Reexamination HAU-RIEGE, STEFAN PETER	
	Examiner Sang Nguyen	Art Unit 2877	Page 1 of 1

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*	U	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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*	X				

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